



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Pan et al.

Serial No.: 09/614,113

Filed: July 12, 2000

For: METHODS OF FORMING A GATE
STACK THAT IS VOID OF SILICON
CLUSTERS WITHIN A METALLIC SILICIDE
FILM THEREOF (AS AMENDED)

Confirmation No.: 1710

Examiner: D. Deo

Group Art Unit: 1765

Attorney Docket No.: 2269-2915.3US
(96-0149.02/US)

CERTIFICATE OF MAILING

I hereby certify that this correspondence along with any attachments referred to or identified as being attached or enclosed is being deposited with the United States Postal Service as First Class Mail on the date of deposit shown below with sufficient postage and in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

July 16, 2004
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Sir:

In accordance with 37 C.F.R. § 1.34(b), please recognize the following individual as an associate agent/attorney herein in connection with the above-identified patent application, and with all continuing and divisional applications hereof:

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